

FORM PTO-1449 (modified) To: U.S. Department of Commerce (PW FORM PAT-1449) Patent and Trademark Office		Atty. Dkt. No.	M#	Client Ref.
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**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Date: October 15, 2003

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Applicant: Heine M. MULDER et al.

Appln. No.: Not Yet Assigned

Filing Date: October 15, 2003

Examiner: Unknown Group Art Unit: Unknown

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR						
BR						
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
OR								
PR								
QR								
RR								
SR								
TR								
UR								
VR								
WR								
XR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

YR	Joseph P. Kirk, "Scattered Light in Photolithographic Lenses", Optical/Laser Microlithography VII (1994), SPIE Vol. 2197, pgs. 566-572			
ZR				
AAR				
BBR				

Examiner

Date Considered:

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